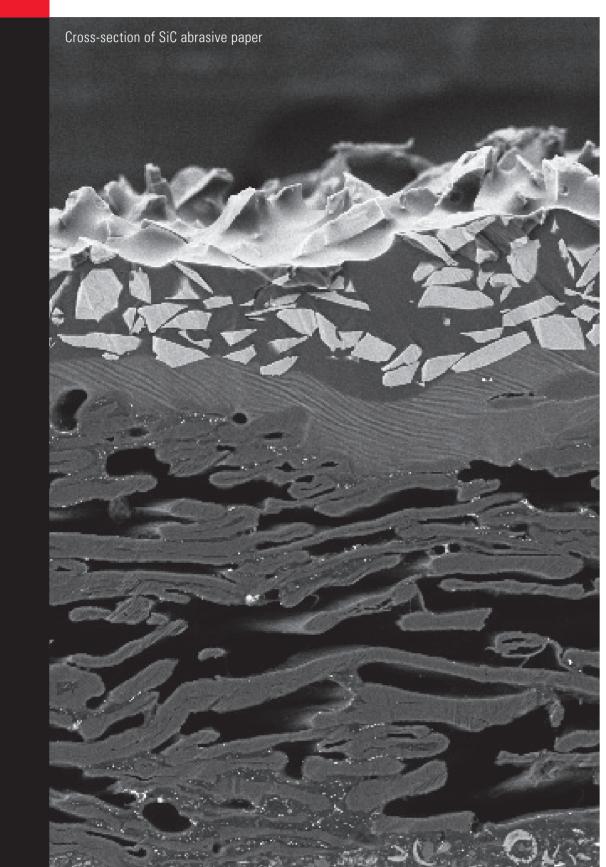
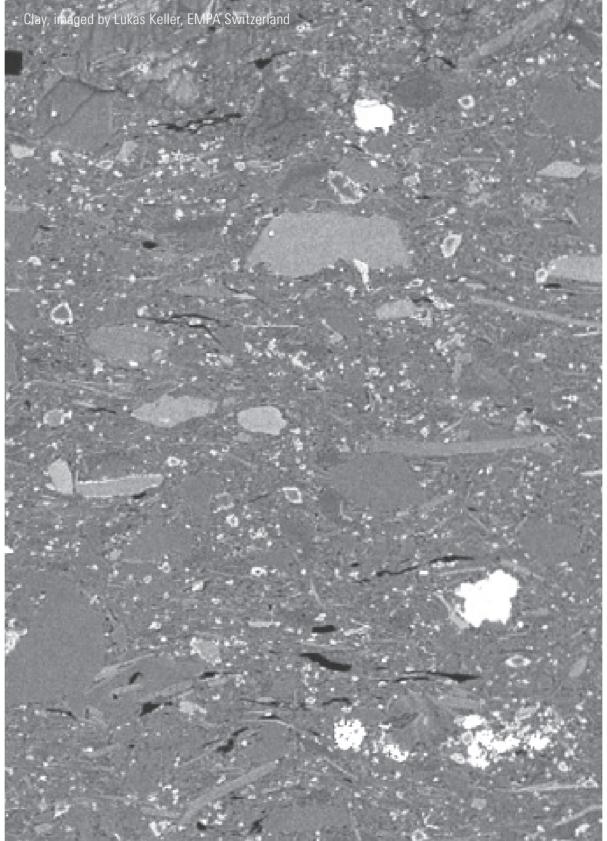
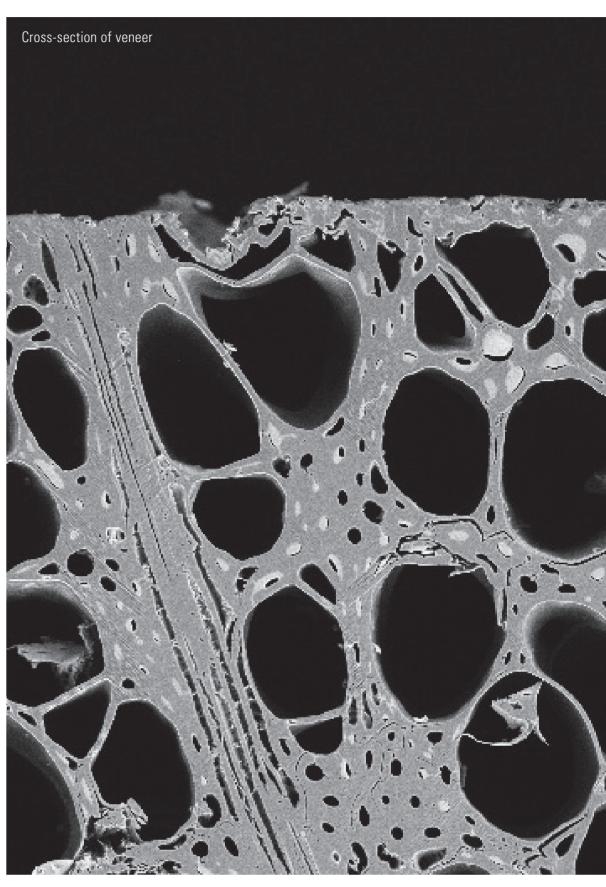
Living up to Life











High Quality Surface Finishing Meets Versatility

Leica EM TIC 3X — Triple Ion-Beam Cutter

- Large surface preparation (exceeding 4 x 1 mm)
- Interchangeable stages
- High sample throughput design multiple sample holder
- Precise targeting and observation system
- Cooling stage for heat-sensitive samples

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